

Docket No.: 01641/0204258-US0
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Karl-Heinz Schuster et al.

Application No.: To be assigned

Confirmation No.:

Filed: June 19, 2006

Art Unit:

For: **MICROLITHOGRAPHY PROJECTION
OBJECTIVE WITH CRYSTAL LENS**

Examiner:

PRELIMINARY AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

Please amend the above-identified U.S. patent application as follows:

Amendments to the Specification are reflected on page 2.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.